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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Kenji WATANABE et al.

Art Unit: 2881

Application Number: 10/543,151

Examiner: Kiet T. Nguyen

Filed: April 18, 2006

Confirmation Number: 2634

For:

MAPPING-PROJECTION-TYPE ELECTRON BEAM APPARATUS FOR INSPECTING SAMPLE BY USING ELECTRONS EMITTED

FROM THE SAMPLE

Attorney Docket Number:

052886

Customer Number:

38834

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 August 1, 2008

Sir:

This paper is submitted in response to the Office Action dated July 1, 2008.

In the Office Action, restriction is required between Group I (Claims 1-5 and 11) and Group II (Claims 6-10 and 12-15).

Applicants hereby elect the subject matter of Group II (Claims 6-10 and 12-15) for prosecution in this application. This election is made without traverse, and it is understood that Applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 U.S.C. §120 and 35 U.S.C. §121 are retained.

Application No.: 10/543,151

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Response to Restriction Requirement

Attorney Docket No.: 052886

If this paper is not timely filed, Applicants respectfully petition for an appropriate extension of time. The fees for such an extension or any other fees that may be due with respect to this paper may be charged to Deposit Account No. 50-2866.

Respectfully submitted,

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